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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re United States Patent Application of:		Docket No.:	2771-594-CIP
Applicants:	WANG, Ziyun, et al.	Conf. No.:	1841
Application No.:	10/699,079	Art Unit:	1621
Date Filed:	November 14, 2002	Examiner:	Samuel A. Barts
Title:	COMPOSITION AND METHOD FOR LOW TEMPERATURE DEPOSITION OF SILICON- CONTAINING FILMS	Customer No.:	23448

FACSIMILE TRANSMISSION CERTIFICATE ATTN: Examiner Samuel A. Barts Fax No. (571) 273-8300

I hereby certify that this document is being filed in the United States Patent and Trademark Office, via facsimile transmission addressed to Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date specified below, and transmitted to United States Patent and Trademark Office facsimile transmission number (571) 273-8300.

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Number of Pages	
 /steven j. hultquist/	
 Steven J. Hultquist	
January 4, 2007	
 Date	

AMENDMENT AND RESPONSE TO OCTOBER 4, 2006 OFFICE ACTION IN U.S. PATENT APPLICATION NO. 10/699,079

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Atty Docket No. 2771-594 CIP

Sir:

In response to the Office Action mailed October 4, 2006, please enter this Amendment and Response into the file of the above-identified application.

A Complete Listing of the Claims is provided herein, beginning on page 3.

Reconsideration of the application is respectfully requested, in view of the amendments made herein to the claims, and the remarks beginning on page 7 hereof.

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